

*Image 2825*

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Satoshi TAKANO

Application No.: 09/819,690

Filed: March 29, 2001

For: SEMICONDUCTOR, MANUFACTURING METHOD, SUBSTRATE PROCESSING  
METHOD, AND SEMICONDUCTOR MANUFACTURING APPARATUS



Group Art Unit: 3148

Examiner: G. Lee

Docket No.: 109107

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Pursuant to 37 CFR §1.56, the attention of the Patent and Trademark Office is hereby directed to the reference(s) listed on the attached PTO-1449. Unless otherwise indicated herein, one copy of each reference is attached. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the reference(s) be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

- 1. This Information Disclosure Statement is being filed before the mailing date of a first Office Action on the merits after the filing of a Request for Continued Examination under 37 C.F.R. §1.114. No certification or fee is required.
- 2. The references were cited in a counterpart foreign application. The foreign Office Action is attached for the Examiner's information.
- 3. English-language Abstracts of the non-English language references are attached hereto.
- 4. A computer-generated English translation of the following Japanese Patent Publication has been obtained from the website of the Japanese Patent Office ([<http://www.jpo.go.jp>]), and is attached, but has not been reviewed for accuracy. See References 2 and 3.

Respectfully submitted,

James A. Oliff  
Registration No. 27,075

David E. Brown  
Registration No. 51,091

JAO:DEB/sqb

Date: March 11, 2004

**OLIFF & BERRIDGE, PLC**  
**P.O. Box 19928**  
**Alexandria, Virginia 22320**  
**Telephone: (703) 836-6400**

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Sheet 1 of 1

Form PTO-1449 (REV. 8-83)		US Dept. of Commerce PATENT & TRADEMARK OFFICE	ATTY DOCKET NO. 109107	APPLICATION NO. 09/819,690		
INFORMATION DISCLOSURE STATEMENT  (Use several sheets if necessary)		APPLICANTS Satoshi TAKANO				
		FILING DATE March 29, 2001	GROUP 3148			
U.S. PATENT DOCUMENTS						
EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS
FOREIGN PATENT DOCUMENTS						
		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB CLASS
	1	JP A 04-100222 w/Eng. Abstr	04/02/1992	Japan		
	2	JP A 06-151558 w/Eng Abstr & Trans	05/31/1994	Japan		
	3	JP A 09-320970 w/Eng Abstr & Trans	12/12/1997	Japan		
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)						
EXAMINER					DATE CONSIDERED	
Examiner: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.						